

# INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(PTO-1449)

ATTY. DOCKET NO.  
43888-132SERIAL NO.  
10/088,484APPLICANT  
Osamu SAKAI, et al.FILING DATE  
March 20, 2002GROUP  
1745

## U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
Dmy		US 5,501,915	03/26/1996	Hards et al.	
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## FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes - Number 4 - Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation	
						Yes	No
Dmy Dmy Dmy		WO 99/40237	08/12/1999	California Institute of Technology			
	A1	DE 196 47 534 (with English abstracts)	05/28/1998				
		JP 10270051 English abstract	09/10/1998	Unitika Ltd.			

## OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.

EXAMINER

DATE CONSIDERED

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1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

<b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>  (PTO-1449)				ATTY. DOCKET NO. <b>43888-132</b>		SERIAL NO. <div style="font-size: 1.5em; font-family: cursive;">10/088484</div>	
				APPLICANT <b>Osamu SAKAI, et al.</b>			
				FILING DATE <b>March 20, 2002</b>		GROUP <div style="font-size: 1.5em; font-family: cursive;">1745</div>	
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
Dwy	5,211,984	5/18/1993	Wilson				
<b>FOREIGN PATENT DOCUMENTS</b>							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
Dwy	10-92440	4/10/1998	Japan (w/ English Abstract)				
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<b>OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)</b>							
Masahiro Watanabe et al., "New Preparation Method of a High Performance Gas Diffusion Electrode Working at 100% Utilization of Catalyst Clusters and Analysis of the Reaction Layer, J. Electroanal. Chem., 197, (1986), pp. 195-208."							
EXAMINER <span style="font-family: cursive; font-size: 1.2em;">Delme</span>				DATE CONSIDERED <span style="font-family: cursive; font-size: 1.2em;">10/17/03</span>			

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